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APPLICANTS

Kohshi Taguchi, Kyoto, JAPAN;
 Masahiro Yoshimoto, Kyoto, JAPAN;

** CONTINUING DATA *****
 This application is a 371 of PCT/JP03/08552 07/04/2003
HEA

** FOREIGN APPLICATIONS *****
 JAPAN 2002-199122 07/08/2002
HEA

** SMALL ENTITY **

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 14	INDEPENDENT CLAIMS 2
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Verified and Acknowledged *[Signature]*
 Examiner's Signature Initials

ADDRESS
 30593
 HARNESS, DICKEY & PIERCE, P.L.C.
 P.O. BOX 8910
 RESTON, VA
 20195

TITLE
 Method and apparatus for forming nitrided silicon film

FILING FEE RECEIVED 450	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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